

CENTRAL FAX CENTER

APR 11 2006

FAX TRANSMISSION**DATE:** April 11, 2006**PTO IDENTIFIER:** Application Number 10/542,447-Conf. #5117
Patent Number**Inventor:** Yoshihiro Taniguchi et al.**MESSAGE TO:** US Patent and Trademark Office**FAX NUMBER:** (571) 273-8300**FROM:** EDWARDS ANGELL PALMER & DODGE LLP
Steven M. Jensen**PHONE:** (617) 439-4444**Attorney Dkt. #:** 63678(70904)**PAGES (Including Cover Sheet):** 7**CONTENTS:** Request for Corrected Filing Receipt (2 pages)
Certificate of Transmission (1 page)

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Docket No.: 63678 (70904)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yoshihiro Taniguchi et al.

Application No.: 10/542,447

Confirmation No.: 5117

Filed: July 15, 2005

Art Unit: 2812

For: FABRICATION METHOD OF
CRYSTALLIZED SEMICONDUCTOR THIN
FILM AND FABRICATION DEVICE
THEREOF

Examiner: Unknown

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby requests that a Corrected Filing Receipt be issued in the above-identified patent application. The Official Filing Receipt received by Applicant, a copy of which is attached hereto, has an error in the title of the application.

Please correct title to:

**Fabrication Method of Crystallized Semiconductor Thin Film and
Fabrication Device Thereof**

Application No.: 10/542,447

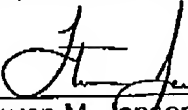
2

Docket No.: 63678(70904)

Applicant additionally requests that all pertinent U.S. Patent and Trademark Office records relating to the subject application be changed to reflect this correction.

Dated: April 11, 2006

Respectfully submitted,

By 
Steven M. Jensen

Registration No.: 42,693
EDWARDS ANGELL PALMER & DODGE
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PTO/SB/97 (09-04)

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Application No. (if known): 10/542,447

Attorney Docket No.: 63678(70904)

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Request for Corrected Filing Receipt (2 pages)

DGC/SMJ 63648
(70904):

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/542,447	07/15/2005	2812	900	63678 (70904)	8	14	3

CONFIRMATION NO. 5117

21874
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P.O. BOX 55874
BOSTON, MA 02205

FILING RECEIPT

OC000000018137426

Date Mailed: 03/01/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Yoshihiro Taniguchi, Nara-shi, JAPAN;
Hiroshi Tsunazawa, Soraku-gun, JAPAN;
Shinya Okazaki, Nara-shi, JAPAN;
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Assignment For Published Patent Application

SHARP KABUSHIKI KAISHA, Osaka, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 21874.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/00161 01/13/2004

Foreign Applications

JAPAN 2003-007631 01/15/2003

Projected Publication Date: 06/08/2006

Non-Publication Request: No

Early Publication Request: No

Title

Crystallized semiconductor thin film manufacturing method and its manufacturing apparatus

Preliminary Class
438FABRICATION METHOD OF CRYSTALLIZED SEMICONDUCTOR
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